

Electronic Acknowledgement Receipt

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Application Number:	10525297
International Application Number:	
Confirmation Number:	6004
Title of Invention:	Process and system for laser crystallization processing of film regions on a substrate to minimize edge areas, and a structure of such film regions
First Named Inventor/Applicant Name:	James S. Im
Customer Number:	21003
Filer:	David W. Schalk
Filer Authorized By:	
Attorney Docket Number:	A35413-PCT-USA (070050.27
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Application Type:	U.S. National Stage under 35 USC 371

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RAM confirmation Number	3149
Deposit Account	024377
Authorized User	

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
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